



1744

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

SHUICHI TAKAYAMA ET AL.

Group Art Unit: 1744

Examiner: Unknown

Serial No.: 10/602,910

Filed: June 24, 2003

For: PATTERNING NANOFEATURES OVER LARGE AREAS

Attorney Docket No.: UOM 0272 PUSP

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If the filing date of this application is on or before June 30, 2003, a copy of each reference listed on the attached Forms PTO/SB08A and/or SB08B is included herewith. If this application was filed after June 30, 2003, copies of any cited U.S. patent/application references

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have not been included. Consideration and entry into the record of these references is respectfully requested.

Respectfully submitted,

**SHUICHI TAKAYAMA ET AL.**

By:   
William G. Conger  
Reg. No. 31,209  
Attorney/Agent for Applicant

Date: January 9, 2004

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Sheet

1

of

3

**Complete if Known**

**Application Number**

310/602,910

Filing Date

June 24, 2003

**First Named Inventor**

SHUICHI TAKAYAMA ET AL.

## Group Art Unit

1744

Examiner Name

Unknown

Attorney Docket Number

UOM 0272 PUSP

## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

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|   |   |    | Applicant Number         | 310/602,910             |               |
|   |   |    | Filing Date              | June 24, 2003           |               |
|   |   |    | First Named Inventor     | SHUICHI TAKAYAMA ET AL. |               |
|   |   |    | Group Art Unit           | 1744                    |               |
|   |   |    | Examiner Name            | Unknown                 |               |
| Sheet   | 2 | of | 3                        | Attorney Docket Number  | UOM 0272 PUSP |

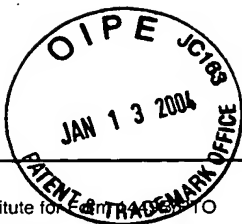
### OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

| Examiner<br>Initials * | Cite No. <sup>1</sup> | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T <sup>2</sup> |
|------------------------|-----------------------|---|----------------|
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